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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Michael DiBattista et al.

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Art Unit: 2815

Serial No.: 10/848,925

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Examiner: Matthew C. Landau

Filed: May 19, 2004

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Atty Docket: ITL.1127US
P19033

For: Physical Nano-Machining With
a Scanning Probe System for
Integrated Circuit Modification

§

Assignee: Intel Corporation

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the restriction requirement mailed August 31, 2006, please amend the above-referenced patent application as follows:

Date of Deposit: September 12, 2006
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
Cynthia L. Hayden